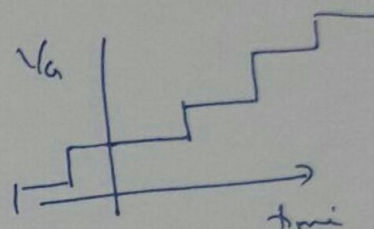
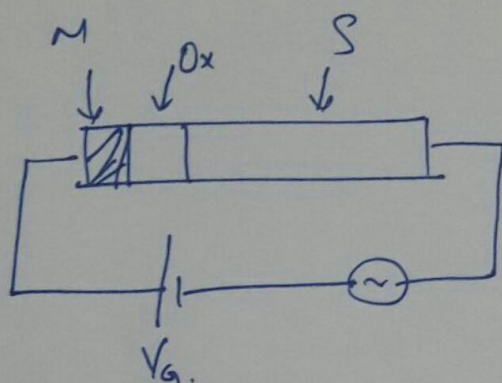


EE 207. MOS Capacitor CV characteristics ①

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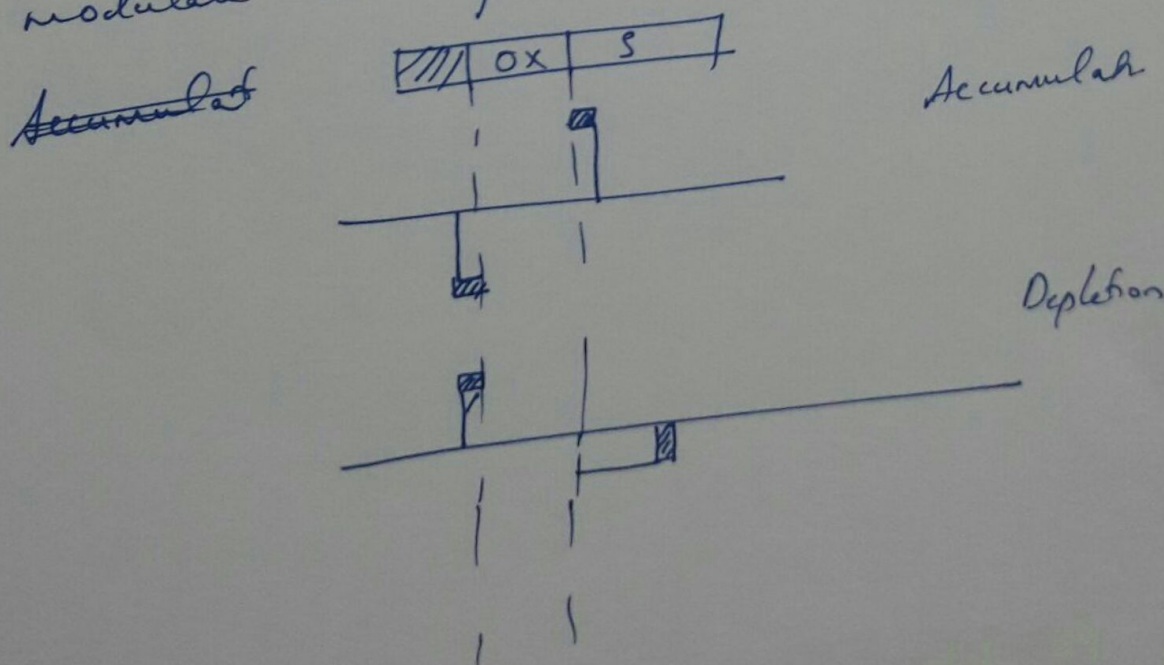
The discussion on MOS electrostatics helped us to identify different regimes of operation. Now we will see how the system responds to an applied small signal AC. The system under consideration is



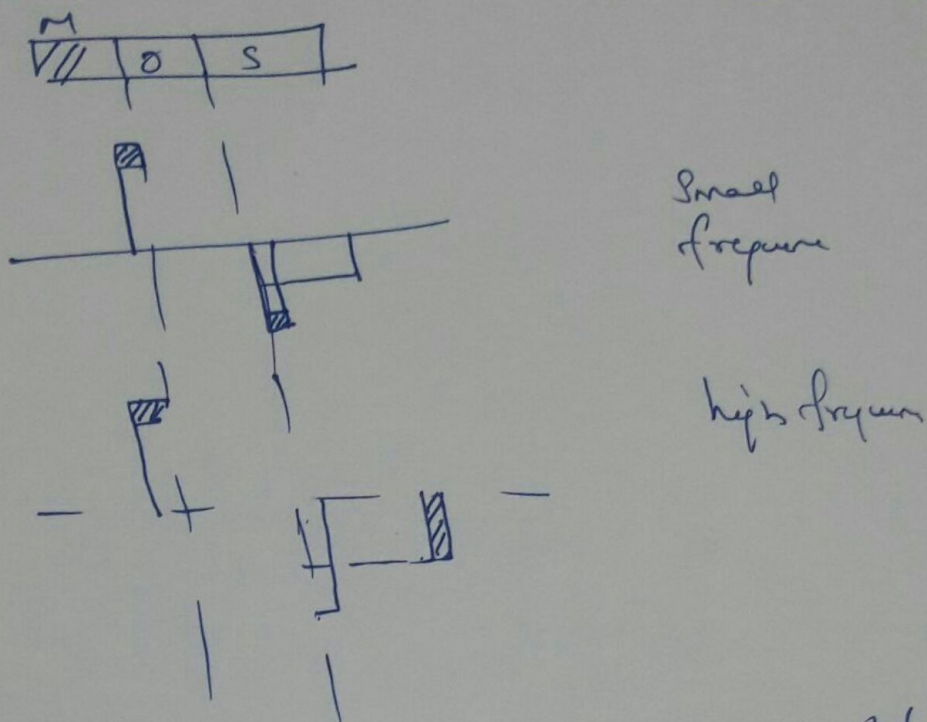
Assumption

- ⊗ V_G is increased very slowly
- ⊗ The system is under steady state
- ⊗ No DC current/leakage through oxide.

For a small signal AC, the charge ~~distributions~~ that modulate its response is as shown below



For inversion, there can be two scenarios ②



As evident from the charge distribution plots we get the following insights

$$C = C_{ox} \quad \leftarrow \text{Accumulation}$$

$$C^{-1} = C_{ox}^{-1} + C_s^{-1} \quad \text{Depletion}$$

where $C_s = \epsilon_s / w_{\text{depletion}}$

$$C^{\Phi} = C_{ox} \quad \text{Inversion, } \omega \text{ very small}$$

$$C^{-1} = C_{ox}^{-1} + C_{s,\text{min}}^{-1} \quad \text{Inversion } \omega \rightarrow \infty$$

$$C_{s,\text{min}} = \frac{\epsilon_s}{w_{\text{depletion,max}}}$$

Hence the system is neither but a series connection of C_{ox} & C_s .

(3)

How to estimate w ?

we know that $Q_d = q N_A w$
 $= (2 \epsilon q N_A \psi_s)^{1/2}$

$$\Rightarrow w_{\text{depletion}} = \left[\frac{2 \epsilon}{q} \left(\frac{1}{N_A} \right) \psi_s \right]^{1/2} \cdot (\psi_s \approx 2 \psi_F)$$

$$w_{\text{depletion, max}} = \left[\frac{2 \epsilon}{q} \frac{1}{N_A} \cdot 2 \psi_F \right]^{1/2} \quad \left[\begin{array}{l} \text{ie, when} \\ \psi_s \approx 2 \psi_F \end{array} \right]$$

Now the capacitance at Flat band conditions

We have from Poisson eqn

$$\epsilon \frac{d^2 \psi}{dx^2} = -q(p - n - N_A)$$

$$p \approx \frac{N_A}{2} e^{-q \psi_0 / kT}$$

$$n \approx \frac{n_i^2}{N_A} e^{q \psi_0 / kT}$$

$$\epsilon \frac{d^2 \psi}{dx^2} = -q \left(N_A e^{-q \psi / kT} - \frac{n_i^2}{N_A} e^{q \psi / kT} - N_A \right)$$

$$\approx -q \left[N_A (1 - 2 \psi_s / kT \dots) - \frac{n_i^2}{N_A} e^{q \psi_s / kT} - N_A \right]$$

$$\epsilon \frac{d^2 \psi}{dx^2} \approx \frac{q^2 N_A \psi_s}{kT}$$

$$\frac{d^2 \psi}{dx^2} \approx \frac{q^2 N_A \psi}{\epsilon kT} \Rightarrow \text{characteristic length.}$$

$$L_D = \left[\frac{\epsilon kT / q}{q N_A} \right]^{1/2}$$

Hence the capacitance at flat band condition ⁽⁴⁾

$$C_s = \frac{\epsilon_s}{L_D}$$

we could arrive this by alternate argument

$$Q^2 = 2q\epsilon \int_0^{\psi} (p - n - N_A) d\psi = 2q \int_0^{\psi} \left(N_A e^{-q\psi/kT} - \frac{n_i^2}{N_A} e^{q\psi/kT} - N_A \right) d\psi$$

$$Q^2 \approx 2q\epsilon \left[-\frac{N_A e^{q\psi/kT}}{kT/q} - 1 \right] - N_A \psi$$

$$Q^2 \approx 2q\epsilon \left[-N_A \left[-\psi + \left(\frac{q}{kT} \right) \frac{\psi^2}{2} \right] - N_A \psi \right]$$

$$Q^2 \approx \frac{2q^2 N_A}{kT/q} \psi^2$$

$$2) \quad Q = \left[\frac{2q^2 N_A}{kT/q} \right]^{1/2} \psi \quad \text{And } Q = C_s V$$

$$2) \quad C_s = \left[\frac{2q^2 N_A}{kT/q} \right]^{1/2} \Rightarrow \epsilon_s / L_D \Rightarrow$$

$$\Rightarrow L_D = \left[\frac{\epsilon kT/q}{2N_A} \right]^{1/2}$$

Typically, for $N_A = 10^{16}$, $\epsilon = 11.8 \times 8.854 \times 10^{-14}$

$$L_D = \left[\frac{11.8 \times 8.854 \times 10^{-14} \times 25 \times 10^{-3}}{1.6 \times 10^{-19} \times 10^{16}} \right]^{1/2}$$

$$\approx 40 \times 10^{-7} \text{ cm} \quad \text{or} \quad 40 \text{ nm} \quad \text{Hence } C_{FB}^{-1} = C_{ox}^{-1} + C_s^{-1}$$

will be different from C_{ox} .

Other interesting points

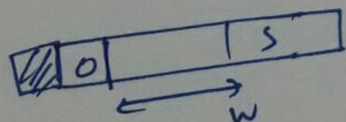
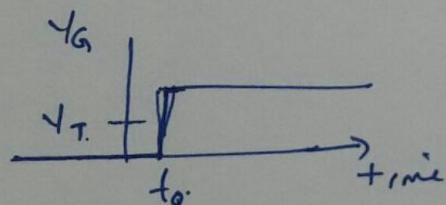
(5)

(A) the inversion layer consist of minority carriers.

The source of such minority carriers is the thermal generation of carriers within the depletion region.

(B) If the applied bias is changed too quickly the inversion layer might not form/respond. This explains why HF capacitance is different from LF capacitance.

(C) If the DC voltage (V_G) is changed too rapidly the electrostatics described in previous section will not be ^{directly} applicable. For example let us apply a step voltage as the gate potential.



At time $t = t_0$, $V_G \geq V_T$

is applied. This will ~~instantaneously~~ create a depletion width w , while

the inversion layer might take a while to build up. So we have

$$V_G = \psi_s + V_{ox} = \psi + \frac{Q_s}{C_{ox}}$$

$$V_G = \psi_s + \frac{(2\epsilon_s \epsilon_0 N_A \psi)^{1/2}}{C_{ox}}$$

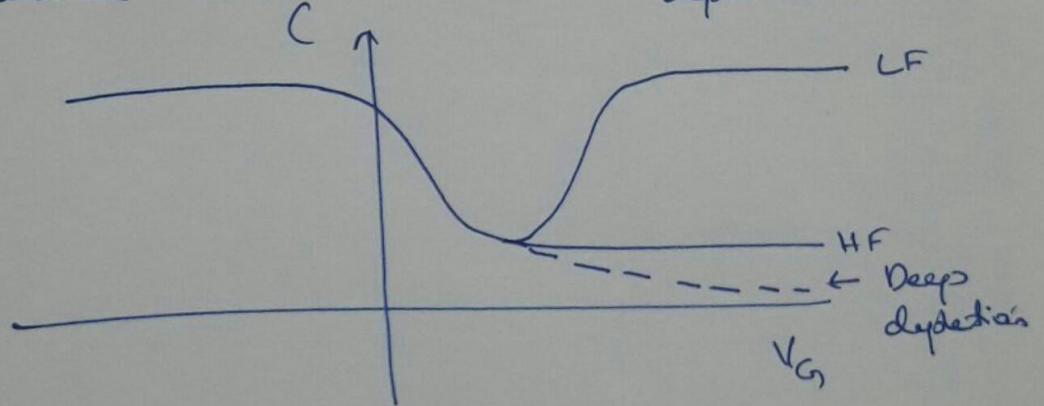
$$Q_s = (2\epsilon_s \epsilon_0 N_A \psi)^{1/2}$$

* Solve for ψ_s and then estimate W . ~~Compare with~~

Compare ψ_s and W with $2\psi_F \approx \left(\frac{2\epsilon}{\epsilon} \frac{1}{N_A} 2\psi_F\right)^{1/2}$ (6)

- (*) Estimate the time taken for the deep inversion region to build up
[Hint: Use SRH R-G in the depletion region]

- (D). The C-V with such a fast DC V_G bias will be different from that of HF & LF CV that we saw earlier. Based on the previous discussion, it is evident that W could be different (ie, larger) from $W_{\text{depletion, max}}$ and hence the capacitance will be lower (known as Deep depletion CV).



- (E). Explore what happens when (a) you shine light, (b) increase temp during CV measure

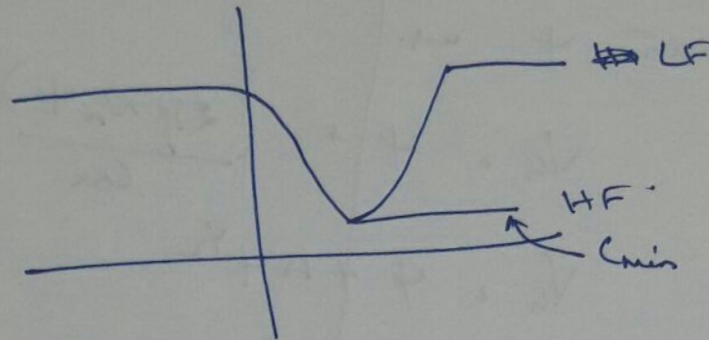
- (F) The capacitance during depletion is given

$$\text{by } \frac{1}{C} = \frac{1}{C_{ox}} + \frac{W}{\epsilon}$$

$$= \frac{1}{C_{ox}} + \frac{1}{\epsilon} \left(\frac{2\epsilon}{\epsilon} \frac{1}{N_A} \psi \right)^{1/2}$$

See whether a relation similar to Mott-Schottky can be obtained for MOS Capacitor.

(C). How to characterize various parameters like t_{ox} , N_A given CV characteristics?



(*) C_{ox} can be estimated from Accumulation and hence t_{ox} .

(*) C_{min} can be used to estimate N_A

$$\frac{1}{C_{min}} = \frac{1}{C_{ox}} + \frac{W_{depletion, max}}{\epsilon_{si}}$$

$$= \frac{1}{C_{ox}} + \frac{\left(\frac{2q \cdot 24F}{\epsilon_{si} N_A} \right)^{1/2}}{\epsilon_{si}}$$

$$\text{With } 24F = \frac{kT}{q} \ln\left(\frac{N_A}{n_i}\right)$$

An derivative Scheme will provide N_A .

(*) Now estimate flat band capacitance and the corresponding voltage. at which ~~FB capacitance~~ this will indicate the presence of any trapped charges in oxide.

(H) Non-idealities in MOS will be discussed later.